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|  | Application Number     |      | 10775458       |  |  |
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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99) | Filing Date            |      | 2004-02-10     |  |  |
|  | First Named Inventor   | John | Heuvel         |  |  |
|  | Art Unit               |      | 3635           |  |  |
| (Not for Submission under 67 of K 1.50)  | Examiner Name          | NGU  | YEN, CHI Q     |  |  |
|  | Attorney Docket Number |      | 049220-9006-00 |  |  |

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|   | 2          | 4724649            |                           | 1988-02-16          | Lowndes, III   |        |  |  |  |
|   | 3          | 4930677            |                           | 1990-06-05          | Jolliffee  |        |  |  |  |
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| Examiner Name          | NGU  | NGUYEN, CHI Q  |  |  |  |  |
| Attorney Docket Number |      | 049220-9006-00 |  |  |  |  |

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